

Inventor: Shozo Nagano et al.  
Title: Physical Vapor Deposition Target  
Assignee: Honeywell International Inc.

**INFORMATION DISCLOSURE STATEMENT**

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References – See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether any of the submitted references is prior art. Copies of the references are attached.

**RECEIVED** Respectfully submitted,

MAR 05 2003

**GROUP 1700**

Dated: 2-26-2003

Attorney:

Jennifer J. Taylor  
Jennifer J. Taylor, Ph.D.  
Reg. No. 48,711